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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Hirofumi WATATANI**

Group Art Unit: **1765**

Serial No.: **10/685,790**

Examiner: **Kin Chan Chen**

Filed: **October 16, 2003**

Confirmation Number: **7016**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR  
DEVICE MANUFACTURING METHOD**

Attorney Docket Number: **032015**

Customer Number: **38834**

**RESPONSE UNDER 37 C.F.R. §1.116**

**- EXPEDITED RESPONSE -**

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Mailstop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

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October 31, 2005

*11/4/05*

Sir:

This paper is being filed in response to the Office Action dated September 28, 2005.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.